

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

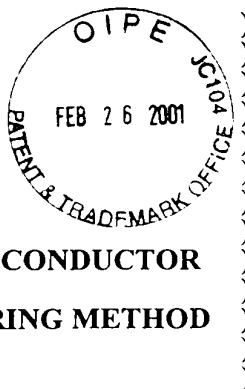
In re Application of:

Shinichi Nagahama et al.

Serial No.: 09/500,288

Filed: February 8, 2000

For: **NITRIDE SEMICONDUCTOR
DEVICE AND
MANUFACTURING METHOD
THEREOF**



**POWER OF ATTORNEY AND
REVOCATION OF PRIOR
POWERS OF ATTORNEY**

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

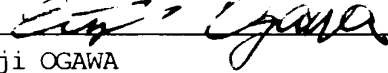
I hereby revoke all prior powers of attorney which may have been filed with this patent.

I hereby appoint the following attorneys/agents to prosecute and transact all business in the Patent and Trademark Office connected therewith, and respectfully request that all correspondence regarding this application and patent, once issued, be directed to:

| | |
|---|---------------------|
| <u>Arthur R. Crawford</u> | (Name) |
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Assignee: Nichia Corporation

Dated: February 16, 2001

By: 
Name: Eiji OGAWA
Title: President

10 2001-02-16 001